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Last Name = JOHN
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**INVENTOR
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Application#	Patent#	Status	Date Filed	Title	Inventor Name 51
60307183	Not Issued	159	07/24/2001	VARIABLE ASPECT RATIO PLASMA SOURCE	JOHNSON, WAYNE L.
60239922	Not Issued	159	10/13/2000	METHOD OF WAFER BAND-EDGE MEASUREMENT USING SPECULAR REFLECTION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	JOHNSON, WAYNE L.
60224217	Not Issued	159	08/10/2000	METHOD AND APPARATUS FOR TUNING A PLASMA REACTOR CHAMBER	JOHNSON, WAYNE L.
60219453	Not Issued	159	07/20/2000	ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	JOHNSON, WAYNE L.
60208568	Not Issued	159	06/02/2000	APPARATUS AND METHOD FOR IMPROVING ELECTRON ACCELERATION	JOHNSON, WAYNE L.
60203909	Not Issued	159	05/12/2000	METHOD OF ADJUSTING THE THICKNESS OF AN ELECTRODE IN A PLASMA PROCESSING SYSTEM	JOHNSON, WAYNE L.
60202174	Not Issued	159	05/05/2000	DEVICE AND METHOD FOR MEASURING PLASMA UNIFORMITY IN-SITU AT WAFER LEVEL	JOHNSON, WAYNE L.
60193250	Not Issued	159	03/30/2000	OPTICAL MONITORING AND CONTROL SYSTEM AND METHOD FOR PLASMA REACTORS	JOHNSON, WAYNE L
60190099	Not Issued	159	03/20/2000	HIGH SPEED PHOTORESIST STRIPPING CHAMBER	JOHNSON, WAYNE L.
60190098	Not Issued	159	03/20/2000	HIGH SPEED STRIPPING FOR DAMAGED PHOTORESIST	JOHNSON, WAYNE L.
60190096	Not Issued	159	03/20/2000	CHUCK TRANSPORT METHOD AND SYSTEM	JOHNSON, WAYNE L.

<u>60189043</u>	Not Issued	159	03/14/2000	METHOD OF WAFER BAND-EDGE MEASUREMENT USING TRANSMISSION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	JOHNSON, WAYNE L.
<u>60186331</u>	Not Issued	159	03/02/2000	ESRF SOURCE FOR ION PLATING EPITAXIAL DEPOSITION	JOHNSON, WAYNE L.
<u>60186279</u>	Not Issued	159	03/01/2000	ELECTRICALLY CONTROLLED PLASMA UNIFORMITY IN A HIGH DENSITY PLASMA SOURCE	JOHNSON, WAYNE L.
<u>60185069</u>	Not Issued	159	02/25/2000	MULTI-ZONE RF ELECTRODE FOR FIELD/PLASMA UNIFORMITY CONTROL IN CAPACITIVE PLASMA SOURCES	JOHNSON, WAYNE
<u>60185068</u>	Not Issued	159	02/25/2000	METHOD AND APPARATUS FOR DEPOSITING FILMS	JOHNSON, WAYNE L.
<u>60182549</u>	Not Issued	159	02/15/2000	ACTIVE CONTROL OF ELECTRON TEMPERATURE IN AN ELECTROSTATICALLY SHIELDED RADIO FREQUENCY PLASMA SOURCE	JOHNSON, WAYNE L.
<u>60182202</u>	Not Issued	159	02/14/2000	STRUCTURE AND THE METHOD FOR MEASURING THE SPECTRAL CONTENT OF AN ELECTRIC FIELD AS A FUNCTION OF POSITION INSIDE A PLASMA	JOHNSON, WAYNE L.
<u>60182188</u>	Not Issued	159	02/14/2000	DEVICE AND METHOD FOR COUPLING TWO CIRCUIT COMPONENTS WHICH HAVE DIFFERENT IMPEDANCES	JOHNSON, WAYNE L.
<u>60182187</u>	Not Issued	159	02/14/2000	METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE L.
<u>29144339</u>	D455662	150	01/01/0001	TOILET TRAINING TIMEPIECE	JOHNSTON, WAYNE L.
<u>10755230</u>	Not Issued	030	01/13/2004	VARIABLE ASPECT RATIO PLASMA SOURCE	JOHNSON, WAYNE L.
<u>10743264</u>	Not Issued	020	12/23/2003	INTER-STAGE PLASMA SOURCE	JOHNSON, WAYNE L.
<u>10685770</u>	Not	030	10/14/2003	CABLE TROUGH METHOD	JOHNSON,

	Issued			WITH SEPARATE SIDE ELEMENTS	WAYNE
<u>10630783</u>	Not Issued	030	07/31/2003	METHOD AND APPARATUS FOR ACTIVE TEMPERATURE CONTROL OF SUSCEPTORS	JOHNSON, WAYNE L.
<u>10626106</u>	Not Issued	030	07/23/2003	TELESCOPING TROUGH	JOHNSON, WAYNE ALBIN
<u>10398652</u>	Not Issued	030	08/29/2003	APPARATUS FOR MEASURING TEMPERATURES OF A WAFER USING SPECULAR REFLECTION SPECTROSCOPY	JOHNSON, WAYNE L.
<u>10031570</u>	Not Issued	041	03/28/2002	ELECTRON DENSITY MEASUREMENT AND PLASMA PROCESS CONTROL SYSTEM USING CHANGES IN THE RESONANT FREQUENCY OF AN OPEN RESONATOR CONTAINING THE PLASMA	JOHNSON, WAYNE L.
<u>09984760</u>	<u>6535785</u>	150	10/31/2001	SYSTEM AND METHOD FOR MONITORING AND CONTROLLING GAS PLASMA PROCESSES	JOHNSON, WAYNE
<u>09969170</u>	<u>6757673</u>	150	10/01/2001	DISPLAYING HIERARCHICAL RELATIONSHIP OF DATA ACCESSED VIA SUBJECT INDEX	JOHNSON, WAYNE L.
<u>09946887</u>	Not Issued	161	09/04/2001	METHOD OF ANALYZING, ORGANIZING AND VISUALIZING CHEMICAL DATA WITH FEATURE HIERARCHY	JOHNSON, WAYNE P.
<u>09927838</u>	<u>6726742</u>	150	08/10/2001	AIR CLEANER WITH A SECONDARY INTAKE	JOHNSON, WAYNE E. A.
<u>09904280</u>	Not Issued	020	07/12/2001	OPTIC CABLE EXIT TROUGH WITH BYPASS	JOHNSON, WAYNE ALBIN
<u>09869766</u>	<u>6559601</u>	150	07/02/2001	PLASMA VACUUM PUMP	JOHNSON, WAYNE L.
<u>09869245</u>	<u>6530342</u>	150	06/27/2001	LARGE AREA PLASMA SOURCE	JOHNSON, WAYNE L.
<u>09686167</u>	<u>6511577</u>	150	10/12/2000	REDUCED IMPEDANCE CHAMBER	JOHNSON, WAYNE L.
<u>09680866</u>	<u>6512875</u>	150	10/06/2000	OPTICAL CABLE TROUGHS, FITTINGS, AND COUPLINGS	JOHNSON, WAYNE
<u>09680700</u>	<u>6625373</u>	150	10/06/2000	CABLE EXIT TROUGH WITH INSERT	JOHNSON, WAYNE
<u>09669279</u>	<u>6631875</u>	150	09/26/2000	CABLE TROUGH WITH SEPARATE SIDE ELEMENTS	JOHNSON, WAYNE

09661892	6478030	150	09/14/2000	METHODS OF ENGAGING AND RELEASING A SURGICAL DEVICE TO A HANDLE	JOHNSON, WAYNE
09637526	Not Issued	041	08/10/2000	HARDWARE-SOFTWARE INTERFACE DESIGNER	JOHNSTON, WAYNE FRANKLIN
09611125	Not Issued	164	07/06/2000	APPARATUS FOR METERING MERCURY FOR LAMP DOSING	JOHNSON, WAYNE
09578300	6739795	150	05/25/2000	TELESCOPING TROUGH	JOHNSON, WAYNE ALBIN
09530946	6425953	150	06/29/2000	ALL-SURFACE BIASABLE AND/OR TEMPERATURE-CONTROLLED ELECTROSTATICALLY-SHIELDED RF PLASMA SOURCE	JOHNSON, WAYNE L.
09509556	6392187	150	05/09/2000	APPARATUS AND METHOD FOR UTILIZING A PLASMA DENSITY GRADIENT TO PRODUCE A FLOW OF PARTICLES	JOHNSON, WAYNE L.
09509549	6339206	150	05/09/2000	APPARATUS AND METHOD FOR ADJUSTING DENSITY DISTRIBUTION OF A PLASMA	JOHNSON, WAYNE L.
09508105	6351683	150	04/19/2000	SYSTEM AND METHOD FOR MONITORING AND CONTROLLING GAS PLASMA PROCESSES	JOHNSON, WAYNE
09508103	6313584	150	04/24/2000	ELECTRICAL IMPEDANCE MATCHING SYSTEM AND METHOD	JOHNSON, WAYNE L.
09508102	6332961	150	06/02/2000	DEVICE AND METHOD FOR DETECTING AND PREVENTING ARCING IN RF PLASMA SYSTEMS	JOHNSON, WAYNE L.
09497901	6209611	150	02/04/2000	COLLAPSIBLE COVER APPARATUS	JOHNSON, WAYNE
09480522	6135420	150	01/07/2000	PORTABLE VEHICLE WHEEL RAISING RAMP	JOHNSTON, WAYNE L.

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 51
60352546	Not Issued	159	01/31/2002	METHOD AND APPARATUS FOR DETERMINATION AND CONTROL OF PLASM STATE	JOHNSON, WAYNE L.
60345648	Not Issued	159	01/08/2002	METHOD AND SYSTEM FOR SORTING DATA	JOHNSTON, WAYNE LESLIE
60343179	Not Issued	159	12/31/2001	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	JOHNSON, WAYNE L.
60337171	Not Issued	159	12/10/2001	METHOD AND DEVICE FOR REMOVING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE
60302361	Not Issued	159	07/03/2001	INTER-STAGE PLASMA SOURCE	JOHNSON, WAYNE L.
60272453	Not Issued	159	03/02/2001	METHOD AND APPARATUS FOR ACTIVE TEMPERATURE CONTROL OF SUSCEPTORS	JOHNSON, WAYNE L.
60262642	Not Issued	159	01/22/2001	VERTICALLY TRANSLATABLE CHUCK ASSEMBLY AND METHOD FOR A PLASMA REACTOR SYSTEM	JOHNSON, WAYNE L.
60256387	Not Issued	159	12/19/2000	WAFER BIAS DRIVE FOR A PLASMA SOURCE	JOHNSON, WAYNE L.
60246113	Not Issued	159	11/07/2000	METHOD OF FABRICATING OXIDES WITH LOW DEFECT DENSITIES	JOHNSON, WAYNE L
60245212	Not Issued	159	11/03/2000	HALL EFFECT ION SOURCE AT HIGH CURRENT DENSITY	JOHNSON, WAYNE
60242714	Not Issued	159	10/25/2000	METHOD OF AND STRUCTURE FOR CONTROLLING ELECTRODE TEMPERATURE	JOHNSON, WAYNE L.
60239436	Not Issued	159	10/10/2000	SYSTEM & METHOD FOR WIRELESS TRACKING	JOHNSON, WAYNE
60238946	Not	159	10/09/2000	DISPLAYING HIERARCHICAL	JOHNSON,

	Issued			RELATIONSHIP OF DATA ACCESSED VIA SUBJECT INDEX	WAYNE L.
<u>60233623</u>	Not Issued	159	09/18/2000	TUNABLE FOCUS RING FOR PLASMA PROCESSING	JOHNSON, WAYNE L.
<u>60200354</u>	Not Issued	159	04/28/2000	METHOD AND APPARATUS FOR DISTRIBUTING GAS WITHIN HIGH DENSITY PLASMA PROCESS CHAMBER TO ENSURE UNIFORM PLASMA	JOHNSON, WAYNE L.
<u>10325828</u>	Not Issued	051	12/23/2002	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	JOHNSON, WAYNE L.
<u>10323917</u>	6690568	150	12/20/2002	FLUID DIELECTRIC VARIABLE CAPACITOR	JOHNSON, WAYNE L.
<u>10307484</u>	Not Issued	030	12/02/2002	APPARATUS AND METHOD FOR IMPROVING ELECTRON ECCELERATION	JOHNSON, WAYNE L.
<u>10291763</u>	Not Issued	030	11/12/2002	METHOD OF ADJUSTING THE THICKNESS OF AN ELECTRODE IN A PLASMA PROCESSING SYSTEM	JOHNSON, WAYNE L.
<u>10283358</u>	6729850	150	10/30/2002	APPLIED PLASMA DUCT SYSTEM	JOHNSON, WAYNE L.
<u>10259845</u>	Not Issued	020	09/30/2002	OPTICAL MONITORING AND CONTROL SYSTEM AND METHOD FOR PLASMA REACTORS	JOHNSON, WAYNE L.
<u>10258606</u>	Not Issued	030	06/02/2003	MEASURING PLASMA UNIFORMITY IN-SITU AT WAFER LEVEL	JOHNSON, WAYNE L
<u>10247561</u>	Not Issued	041	09/20/2002	CHUCK TRANSPORT METHOD AND SYSTEM	JOHNSON, WAYNE L.
<u>10239857</u>	Not Issued	030	10/02/2002	METHOD AND APPARATUS FOR DISTRIBUTING GAS WITHIN HIGH DENSITY PLASMA PROCESS CHAMBER TO ENSURE UNIFORM PLASMA	JOHNSON, WAYNE L.
<u>10229036</u>	Not Issued	020	08/28/2002	ELECTRICALLY CONTROLLED PLASMA UNIFORMITY IN A HIGH DENSITY PLASMA SOURCE	JOHNSON, WAYNE L.
<u>10227527</u>	Not Issued	030	08/26/2002	MULTI-ZONE RF ELECTRODE FOR FIELD/PLASMA UNIFORMITY CONTROL IN CAPACITIVE PLASMA SOURCES	JOHNSON, WAYNE

<u>10227526</u>	Not Issued	095	08/26/2002	METHOD AND APPARATUS FOR DEPOSITING FILMS	JOHNSON, WAYNE L.
<u>10222991</u>	Not Issued	061	08/19/2002	WEATHER RESISTANT ANTI-SLIP PANELS	JOHN, WAYNE MORGAN
<u>10218090</u>	Not Issued	030	08/14/2002	STRUCTURE AND THE METHOD FOR MEASURING THE SPECTRAL CONTENT OF AN ELECTRIC FIELD AS A FUNCTION OF POSITION INSIDE A PLASMA	JOHNSON, WAYNE L.
<u>10218036</u>	Not Issued	030	08/14/2002	METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	JOHNSON, WAYNE L.
<u>10218029</u>	Not Issued	092	08/14/2002	ACTIVE CONTROL OF ELECTRON TEMPERATURE IN AN ELECTROSTATICALLY SHIELDED RADIO FREQUENCY PLASMA SOURCE	JOHNSON, WAYNE L.
<u>10204448</u>	Not Issued	061	09/03/2002	HIGH SPEED PHOTORESIST STRIPPING CHAMBER	JOHNSON, WAYNE L.
<u>10204263</u>	Not Issued	094	08/20/2002	HIGH SPEED STRIPPING FOR DAMAGED PHOTORESIST	JOHNSON, WAYNE L.
<u>10204002</u>	Not Issued	093	08/16/2002	ESRF SOURCE FOR ION PLATING EPITAXIAL DEPOSITION	JOHNSON, WAYNE L.
<u>10201560</u>	Not Issued	071	07/23/2002	PACKAGE FOR REMOVABLE DEVICE TIPS	JOHNSON, WAYNE
<u>10189425</u>	Not Issued	041	07/08/2002	SEGMENTED ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	JOHNSON, WAYNE
<u>10175806</u>	Not Issued	041	06/21/2002	METHOD AND SYSTEM FOR REDUCING DAMAGE TO SUBSTRATES DURING PLASMA PROCESSING WITH A RESONATOR SOURCE	JOHNSON, WAYNE L.
<u>10168544</u>	Not Issued	041	07/02/2002	METHOD OF WAFER BAND-EDGE MEASUREMENT USING TRANSMISSION SPECTROSCOPY AND A PROCESS FOR CONTROLLING THE TEMPERATURE UNIFORMITY OF A WAFER	JOHNSON, WAYNE L.
<u>10149452</u>	6630364	150	06/27/2002	SYSTEM FOR AUTOMATIC CONTROL OF THE WALL BOMBARDMENT TO CONTROL WALL DEPOSITION	JOHNSON, WAYNE L.

10043270	6740842	150	01/14/2002	RADIO FREQUENCY POWER SOURCE FOR GENERATING AN INDUCTIVELY COUPLED PLASMA	JOHNSON, WAYNE L.
10031374	6741944	150	05/22/2002	ELECTRON DENSITY MEASUREMENT AND PLASMA PROCESS CONTROL SYSTEM USING A MICROWAVE OSCILLATOR LOCKED TO AN OPEN RESONATOR CONTAINING THE PLASMA	JOHNSON, WAYNE L.
09871026	Not Issued	168	05/31/2001	METHOD FOR PREVENTING TELESCOPING OF SPIRAL WOUND FILTRATION MODULES	JOHNSON, WAYNE
09813936	Not Issued	071	03/22/2001	WEATHER RESISTANT ANTI-SLIP PANELS	JOHN, WAYNE MORGAN
09774183	6385977	150	02/05/2001	ESRF CHAMBER COOLING SYSTEM AND PROCESS	JOHNSON, WAYNE L.
09774182	6491742	150	02/05/2001	ESRF COOLANT DEGASSING PROCESS	JOHNSON, WAYNE L.
09749469	6422825	150	12/28/2000	PLASMA VACUUM PUMPING CELL	JOHNSON, WAYNE L.
09707182	6522823	150	11/06/2000	LOW PROFILE CABLE EXIT TROUGH	JOHNSON, WAYNE
09684643	6470129	150	10/10/2000	MODULAR CABLE MANAGEMENT TROUGH SECTION	JOHNSON, WAYNE
09680779	6535683	150	10/06/2000	CABLE EXIT TROUGH WITH COVER	JOHNSON, WAYNE
09680700	6625373	150	10/06/2000	CABLE EXIT TROUGH WITH INSERT	JOHNSON, WAYNE
09661895	6358241	150	09/14/2000	PACKAGE FOR REMOVABLE DEVICE TIPS	JOHNSON, WAYNE

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Your Search was:

Last Name = KETTLEWELL

First Name = NEIL

Application#	Patent#	Status	Date Filed	Title	Inventor Name 2
10222991	Not Issued	061	08/19/2002	WEATHER RESISTANT ANTI-SLIP PANELS	KETTLEWELL, NEIL
09813936	Not Issued	071	03/22/2001	WEATHER RESISTANT ANTI-SLIP PANELS	KETTLEWELL, NEIL

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Last Name = RIPLEY

First Name = CATHERINE

Application#	Patent#	Status	Date Filed	Title	Inventor Name 5
29091754	D425627	150	08/05/1998	ROAD SPEED HUMP COMPONENT	RIPLEY, CATHERINE JANET
29073341	D402669	150	07/07/1997	LINE MARKER	RIPLEY, CATHERINE J.
10222991	Not Issued	061	08/19/2002	WEATHER RESISTANT ANTI-SLIP PANELS	RIPLEY, CATHERINE JANET
09813936	Not Issued	071	03/22/2001	WEATHER RESISTANT ANTI-SLIP PANELS	RIPLEY, CATHERINE JANET
09117398	6102305	150	02/25/1999	LINE MARKING APPLICATORS	RIPLEY, CATHERINE J.

Inventor Search Completed: No Records to Display.

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